



PATENT  
930055-2031

2834

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

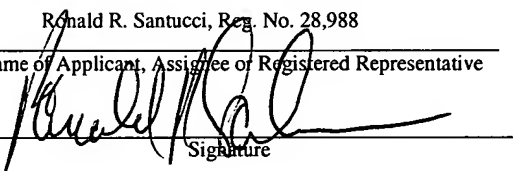
Applicant(s) : Tetsuo YAMADA, Kosuke NISHIMURA, Keigo NAGAO  
Serial No. : 10/518,704  
For : THIN FILM PIEZOELECTRIC RESONATOR, THIN  
FILM PIEZOELECTRIC DEVICE, AND  
MANUFACTURING METHOD THEREOF (as proposed  
for amendment)  
Filing Date : December 17, 2004  
Examiner : Not Yet Assigned  
Group Art Unit : 2834  
Confirmation No. : 5674

745 Fifth Avenue  
New York, NY 10151

I hereby certify that this correspondence is being deposited with  
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Alexandria, VA 22313-1450, on August 18, 2005.

Ronald R. Santucci, Reg. No. 28,988

Name of Applicant, Assignee or Registered Representative



Signature

August 18, 2005

Date of Signature

**SECOND PRELIMINARY AMENDMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

Preliminary to the examination of the above referenced patent application,

Applicants respectfully request that the application be further amended as follows:

In the Title:

Applicants respectfully request that the title of the application be amended as follows:

THIN FILM PIEZOELECTRIC ~~OSCILLATOR~~ RESONATOR, THIN FILM  
PIEZOELECTRIC DEVICE, AND MANUFACTURING METHOD THEREOF